Workshop on Scanning Probe Nanotechnology

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Scanning Probe Microscopes: powerful tools to create, manipulate and characterize objects at the nanometer scale

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Abstract

Since several years, Scanning Probes Microscopes are widely used to study and to characterize surfaces from micro to atomic scale. More recently, a new approach is intensively developed: using the SPM as a tool for fabrication, modification and/or manipulation of nano-objects [1]. With this original approach, nano-objects can be fabricated or manipulated and just after characterized by a non-destructive technique.

The first part of this talk focuses on the fabrication of nano-objects following by their characterization through three different examples:

- Nano-oxidation of hydrogenated silicon surface by AFM and elaboration of nanotransistors [2].
- CVD assisted by STM: elaboration of Rh nano-clusters [3].
- Surface patterning by SNOM and UV Raman SNOM characterization [4, 5].

For these three examples, their advantages and disadvantages will be listed and discussed.

The second part of the talk focuses on the manipulation of:

- Nano-objects on a surface as carbon nanotubes on a nano-structured surface and how to deduce information about adhesive properties from this kind of experiments [6].
- Elementary particles. Electric charges can be injected in nanostructures or in a dielectric layer by applying a voltage between the AFM tip and the sample. EFM (Electrostatic Force Microscopy) allows characterizing their space-time evolution [7].

References:

[1] B. M. Eigler, E. K. Schweizer, Nature 344, 524 (1990).

- [2] F. Marchi, V. Bouchiat, H. Dallaporta, V. Safarov, D. Tonneau, P. Doppelt, J. Vac. Sci. Technol.B 16, 2952-2956 (1998).
- [3] F. Marchi, V. Bouchiat, H. Dallaporta, V. Safarov, D. Tonneau, P. Doppelt, J. Vac. Sci. Technol.B 18, 1171-1176 (2000).
- [4] M. K. Herndon, R. T. Collins, R.E. Hollingsworth, P. R. Larson, M. B. Johnson, Appl. Phys. Lett., 74, 141-144 (1999).
- [5] H. Sand, F. Demongeot, S. Webster, E. Bonera, R. Bennet, I. P. Hayward, F. Marchi, A. Smith, D. N. Batchelder, J. Raman Spectrosc., 33, 730-739 (2002).
- [6] S. Decossas, G. Cappello, G. Poignant, L. Patrone, A. M. Bonnot, F. Comin and J. Chevrier, Europhys. Lett. 53, 742 (2001).

[7] C. Guillemot, P. Budau, J. Chevrier, F. Marchi, F. Comin, C. Alandi, F. Bertin, N. Buffet, Ch. Wyon, P. Mur, Europhys. Lett., **59**, 566-571 (2002).